



Docket No.: SON-2612/DIV  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shigeru Fujita

Application No.: 10/785,005

Confirmation No.: 9742

Filed: February 25, 2004

Art Unit: 2814

For: SEMICONDUCTOR DEVICE AND ITS  
MANUFACTURING METHOD

Examiner: LE, Thao X

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

Please  
Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Do Not Enter  
TL  
01/29/06

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated December 12, 2005, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.